



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 23, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG670430557

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.41 - 6.45 X 4.04 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.04 CARAT

D

VVS 2

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

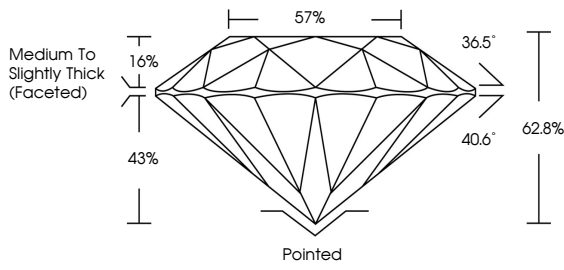
EXCELLENT

NONE

 LG670430557

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

57%

36.5°

40.6°

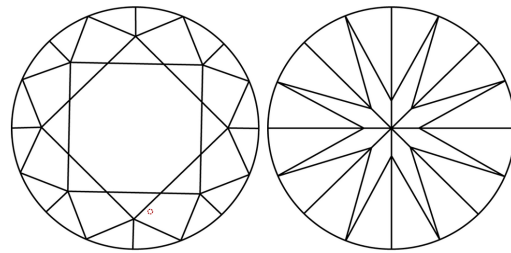
62.8%

43%

16%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



December 23, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG670430557

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.41 - 6.45 X 4.04 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.04 CARAT

D

VVS 2

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

 LG670430557

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI

December 23, 2024

IGI Report No LG670430557

ROUND BRILLIANT

6.41 - 6.45 X 4.04 MM

Color Grade

Clarity Grade

Depth

Table

Graile

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.04 CARAT

D

VVS 2

EXCELLENT

62.8%

57%

None

EXCELLENT

EXCELLENT

NONE

 LG670430557

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa